



Docket No. 5000-5118

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Tomohei SUGIYAMA et al.      Group Art Unit: 2891  
Serial No : 10/626,418      Examiner: D. Menz  
Filed : July 23, 2003  
For : METHOD OF MANUFACTURING A LOW EXPANSION MATERIAL  
AND SEMICONDUCTOR DEVICE USING THE LOW EXPANSION  
MATERIAL

**AMENDMENT UNDER 37 C.F.R. §1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action (final rejection) dated March 3, 2006,

Applicants respectfully request reconsideration in view of the following amendments and  
remarks.

Amendments to the Claims are reflected in the listing of claims which begins on  
page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.